

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuo KOBAYASHI, et al.

Serial No.: 10/549,859

Filed: June 6, 2006

For: PLASMA-ASSISTED DEPOSITION METHOD
AND PLASMA-ASSISTED DEPOSITION
SYSTEM

Confirmation No. 7185

Art Unit: 1792

Examiner: Michael G. Miller

Atty. Dckt: 033082 M 280

PETITION FOR A THREE-MONTH EXTENSION OF TIME

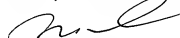
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is a Petition for an Extension of Time for a Three month period. This Petition for Extension of Time is being concurrently filed with an Amendment.

Payment of the requisite fee is being made with a credit card using EFS-Web.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP



Michael A. Makuch
Reg. No. 32,263

Date: August 23, 2010
1130 Connecticut Ave., NW, #1130
Washington, D.C. 20036
Telephone: (202) 263-4300
Facsimile: (202) 263-4329